

Docket Number: 071469-0306508
Client Reference: PC0187A 2

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

ANDREJ S MITROVIC

Group Art Unit:

Application No.:

Examiner:

Filed: November 25, 2003

Confirmation No.:

For: PLASMA PROCESSING SYSTEM AND METHOD

INFORMATION DISCLOSURE STATEMENT

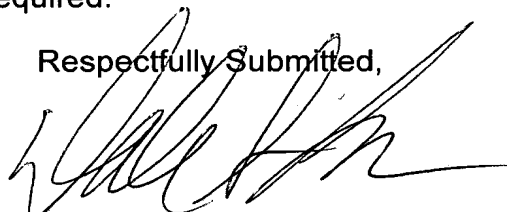
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. As this application is being filed after June 30, 2003, no copies of the cited U.S. patents are enclosed; however, a copy of each non-patent literature reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed with the Non-Provisional application. No certification or fee is required.

Respectfully Submitted,



Dale S. Lazar
Registration Number 28872

Date: November 25 2003

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Substitute for form 1449A/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet

1

of

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Complete if Known

Application Number	
Filing Date	11/25/2003
First Named Inventor	ANDREJ S MITROVIC
Art Unit	
Examiner Name	
Attorney Docket Number	071469-0306508

U. S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)				
	1	US- 6,613,588	B2	09-02-2003	NAKANO et al.	
	2	US- 5,294,806		03-15-1994	BATCHELDER et al.	
	3	US- 5,192,870		03-9-1993	BATCHELDER et al.	
	4	US- 5,622,595		04-22-1997	GUPTA et al.	
	5	US- 5,328,555		07-12-1994	GUPTA	
	6	US- 6,576,559	B2	06-10-2003	NAKATA et al.	
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FOREIGN PATENT DOCUMENTS

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Examiner Initials*	Cite No.	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶	
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)					

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This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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Substitute for form 1449B/PTO			Complete if Known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)			Application Number		
			Filing Date	11/25/2003	
			First Named Inventor	ANDREJ S MITROVIC	
			Art Unit		
			Examiner Name		
Sheet	1	of	1	Attorney Docket Number	071469-0306508

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	A	WOLBERG , "Spatial Transformations," Digital Image Warping, IEEE Computer Society Press (Los Alamitos, CA 90720), p. 41-94, (1990).	
	B	SELWYN ET AL., "Rastered laser light scattering studies during plasma processing: Particle contamination trapping phenomena," J.Vac.Sci. Technol., American Vacuum Society, Vol. A9 (No. 5), p. 2817-2824, (September/October 1991).	
	C	SELWYN ET AL., "Trapping and behavior of particulates in a radio frequency magnetron plasma etching tool," J.Vac.Sci. Technol., American Vacuum Society, Vol. A 1 (No. 4), p. 1132-1135, (July/August 1993).	
	D	SELWYN, "5.4 Particulate Detection by Laser Light Scattering," Optical Diagnostic Techniques for Plasma Processing, M-11, American Vacuum Society, p. 135-138, 151-152, (1993).	
	E	CARLILE ET AL., "Electrostatic trapping of contamination particles in a process plasma environment," Applied Physics Letter, American Institute of Physics, Vol. 59 (No. 10), p. 1167-1169, (September 2, 1991).	
	F	SELWYN ET AL., "Particle trapping phenomena in radio frequency plasmas," Apply. Phys. Lett., American Institute of Physics, Vol. 57 (No. 18), p. 1876-1878, (October 29, 1990).	

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 120 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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